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PTO/SB/08b (08-03)

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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

**Complete if Known**

Application Number	
Filing Date	01/23/2004
First Named Inventor	TADAHIRO OHMI
Art Unit	2818
Examiner Name	
Attorney Docket Number	040258-0307828

Sheet 1 of 1

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
DV	1	ITO ET AL., "Silicon Oxynitridation With Inductively Coupled Oxygen-Nitrogen Mixed Plasma," Jpn. J. Appl. Phys., p. 612-616, ( 1997).	
DV	2	HIRAYAMA ET AL., "Low Temperature Growth of High-Integrity Silicon Oxide Films by Oxygen Radical Generated in High-Density Krypton-Plasma," IEEE, p. 249-252, ( 1999).	
DV	3	SAITO ET AL., "Low Temperature Formation of Gate-Grade Silicon Nitride Film Employing Microwave-Excitation High-Density Plasma," Technical Report, IEICE, p. 85-90, ( 1999).	

Examiner  
Signature*Richard*Date  
Considered

09/07/05

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## U. S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	R <sup>o</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (If known)				
DV	A	JP 5-267684	10-00-1993	OZAWA		
DV	B	JP 259-105371	06-00-1984	KOMORI		
DV	C	JP 8-51164	02-00-1996	MORITA		
DV	D	JP 9-205155	08-00-1997	TAKABAYASHI		
DV	E	JP 9-213820	08-00-1997	USHIYAMA et al.		

Examiner Signature	<i>Phillips</i>	Date Considered	09/07/05
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DV	F	JP	9-223752	08-00-1997	MINE		
DV	G	JP	PCT/JP01/01967	03-00-2001			

Examiner Signature	<i>[Signature]</i>	Date Considered	09/07/05
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